

Speaker: Dr. Kazuhiro Murata

SITechnology, Inc., CEO, Inventor of Super Inkjet technology

## Title: Direct fabrication of micron-scale structures using Super Inkjet

**Abstract**: We have developed a super-fine inkjet technology (SIJ) that enables extremely fine pattern formation using droplets measuring less than 1 micrometer in diameter. By using conductive ink based on nano-metal particles, direct fabrication of circuits and three-dimensional structures having a feature size of just a few microns are achieved. Moreover the SIJ is capable of printing with a wide variety of inks, for example, insulators, organic semiconductors, light emitting polymers, bio-materials and UV curable polymers. The potential of the SIJ technology and its application to cutting-edge areas, such as flexible electronics, printed electronics, fine interconnect and others will be shown.

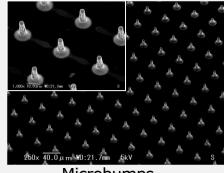
Come and find out more about a unique interdisciplinary nano-building tool.

If you would like to meet with Dr. Shimizu after the talk, please email

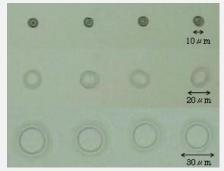
Dr. Savas Kaya (kaya@ohio.edu)



Silver ink, L/S=1µm



Microbumps d=5µm, H=20µm



Protein material (albumin)